

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1829		SERIAL NO. 10/072,440	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT H. Daniel Dulman			
				FILING DATE Feb. 5, 2002 [RCE Filed Herewith]		GROUP 1756	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
DL	AA	5,629,113	05/97	Watanabe	430	5	
	AB	6,007,324	12/99	Tzu et al.	RECEIVED		5
	AC	5,384,219	01/95	Dao et al.	FEB 10 2004		5
	AD	5,300,379	01/94	Dao et al.	OFFICE OF PETITIONS		5
DL	AE	5,897,975	04/99	Ahn et al.	430	5	
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AL	US 03/ 02288	01/03	PCT Search Report				
AM	0 395 425 A2/A3	04/90	EPO				
AN	0 583,942 A2	08/93	EPO				
	AO						
	AP						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
AQ	Cui, Z. et al., "Partial Rim: A New Design of Rim Phase Shift Mask for Submicron Contact Holes", SPIE						
AR	Vol. 2440, Feb. 1995, pp. 541-549.						
EXAMINER				DATE CONSIDERED			
[Signature]				3/2/04			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							